

IN THE US PATENT AND TRADEMARK OFFICE

*S. Wilch*  
*8-1-01*  
*Pre-Amendment*  
*#3*

Application Number: Not yet assigned  
Filing Date: Filed herewith  
5 Applicant: Robert E. Fontana et al.  
Application Title: Fully Undercut Resist Systems Using  
E-Beam Lithography for The  
Fabrication of High Resolution MR  
Sensors  
10 Examiner: Not yet assigned  
Art Unit: Not yet assigned

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, DC 20231, on	
<u><i>Tiantina Gu</i></u> Name of Person Signing	<u><i>5/10/01</i></u> date of deposit
<u><i>5/10/01</i></u> date	

PRELIMINARY AMENDMENT

Commissioner of Patents and Trademarks  
Washington, DC 20231

Sir:

Prior to examination, kindly amend the above application as follows:

**SPECIFICATION:**

Kindly replace the "Brief Description of The Figures" section and indicated paragraphs of the specification with the amended version below. A marked-up version of the "Brief Description of The Figures" section and the indicated paragraphs is attached on separate pages.